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FIG. 3

low pressure CVD system

'01 01/15 MON 20:21 FAX 03 3402 4660 ...

timer set time period

host computer

request for loading wafer lots (S501)

notice of the lots to be processed (S502)
(Lot ID: A, B, C)

request for loading wafer lots (A, B) (S503)

instruct to output and carry lots (A, B) (S504)

request for loading wafer lot (C) (S505)

instruct to output and carry lot (C) (S504, S506)

request for inhibiting the load (S505)

" prior art

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